

# Experiment Brief

## Vulcan Cathodoluminescence Detector

### Title

Mapping the electronic band gap of semiconductor compounds with milli-electron volt accuracy

### Gatan instrument used

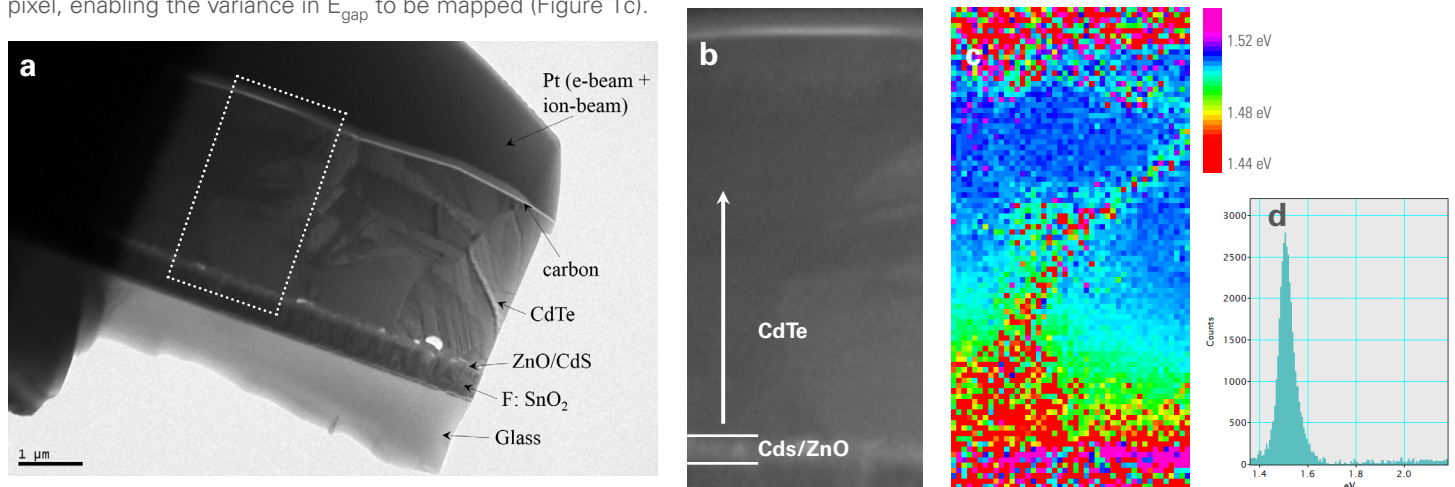
The Vulcan™ system is the first commercial cathodoluminescence (CL) system for transmission electron microscopes (TEM) to enable the direct correlation of the optical and structural properties of materials at the nanoscale.

### Background

The energy band gap ( $E_{\text{gap}}$ ) is an important feature of semiconductors that determines their use in electronics and optoelectronics applications. Through control of a semiconductor's band gap, scientists and engineers can design novel devices and optimize device designs. However, with the explosion in nanotechnologies, determining  $E_{\text{gap}}$  at a meaningful spatial resolution is increasingly complex. The device has a graded  $E_{\text{gap}}$  formed by sulfur (S) diffusion into the CdTe absorber during thermal processing. Here we demonstrate how to reveal the change in  $E_{\text{gap}}$  by analyzing the photons emitted due to radiative recombinations after the sample is excited by the focused electron beam of a TEM.

### Materials and Methods

A cross-sectional TEM sample was prepared using focused ion beam lift out before the grain structure was revealed using TEM and STEM imaging modes (Figure 1a and 1b);  $E_{\text{gap}}$  was then mapped using CL spectrum imaging. CL spectrum imaging records a full CL spectrum – intensity versus wavelength (or energy) – at each location of the electron beam. The non-linear least squares fitting routine of DigitalMicrograph® software was used to determine the center of the dominant peak (corresponding to the  $A^{\circ}X$  exciton) at each pixel, enabling the variance in  $E_{\text{gap}}$  to be mapped (Figure 1c).



**Figure 1.** a) TEM image of a polycrystalline CdS/CdTe solar cell. b) and c) show correlated TEM image and band gap map. The band gap map was extracted from a CL spectrum image of the region indicated by the rectangle in a). A typical CL spectrum from the spectrum image is displayed in d) from which the band gap at each pixel was determined using the non-linear least squares method. An alloy with 17% S was observed immediately adjacent to the CdS layer ( $E_{\text{gap}}$  reduced by 83 meV), and S was found to diffuse  $>1.45 \mu\text{m}$  into the grain centers. However, enhanced S diffusion at grain boundaries resulted in through-thickness diffusion of S with grain boundaries at the backside of the device exhibiting a band gap reduction of 13 meV, corresponding to an S content  $\sim 1\%$ .

### Summary

The band gap of the compound semiconductor  $\text{CdTe}_{1-x}\text{S}_x$  was mapped in the TEM by measuring the band-to-band luminescence using the Vulcan system. Reduction in the local band gap was observed associated with sulfur diffusion during thermal processing. Due to the intrinsically low background of CL and the high energy (wavelength) resolution of the Vulcan system, the band gap could be determined with better than 10 meV resolution.

### Credit(s)

Special thanks to Prof. Ken Durose, University of Liverpool for providing the sample and Dr. Ashley Howkins and the Experimental Technique Centre (ETC), Brunel University, London for generously allowing access to the microscope and Vulcan detector used in this work.

**Gatan, Inc.** is the world's leading manufacturer of instrumentation and software used to enhance and extend electron microscopes—from specimen preparation and manipulation to imaging and analysis.

**Dr. Budhika Mendis** is a lecturer at Department of Physics and service manager for the G.J. Russell Electron Microscopy Facility at Durham University. His research interests include using electron microscopy as a tool to investigate a wide range of materials science problems, with particular focus in thin-film solar cell materials as well as modelling electron beam-specimen interactions and developing image and spectroscopic data analysis methods.